

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :  
Toshio KODAMA et al. :  
Serial No. (not yet assigned) :  
Filed: January 11, 2005 :  
  
For: ION BEAM APPARATUS, AND :  
ION BEAM PROCESSING :  
METHOD, AND HOLDER :  
MEMBER : Docket No. S004-5433 (PCT)

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MS PCT  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

SECOND PRELIMINARY AMENDMENT

S I R:

Applicants preliminarily amend their application as follows:

ADDITIONAL FEE:

No additional fees is believed required in connection with this amendment; however, should it be determined that a fee is due, authorization is hereby given to charge any such fee to our Deposit Account No. 01-0268.

BY EXPRESS MAIL ON JANUARY 11, 2005 (EV 504 368 240 US)